Attorney's Docket No.: 042390P8125D

Patent

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In re Application of:		)	
	Qing Ma et al.	) Examiner: Not yet assigned )	
Serial No.:	Not yet assigned	) Art Unit: Not yet assigned )	
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## FORMAL DRAWINGS SUBMISSION

Enclosed herewith for submission in the United States Patent and Trademark

Office are two (2) sheets of formal drawings for the patent application referenced above.

If there are any further charges please charge them to Deposit Account No. 02-2666. A duplicate of this sheet is enclosed for that purpose.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Dated: 1/2/02 2001

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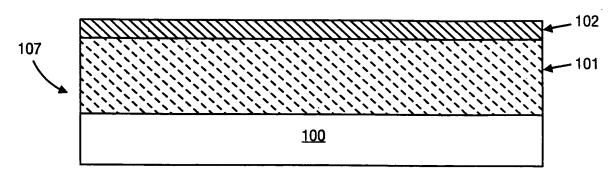


FIG. 1a

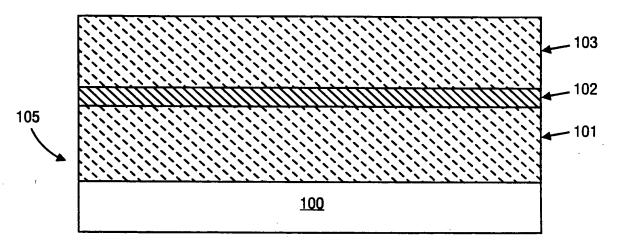


FIG. 1b

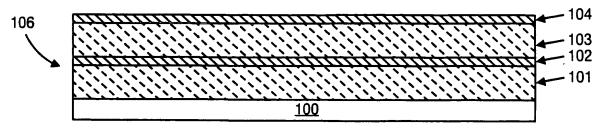


FIG. 1c

